IN THE CLAIMS:

Cancel claims 3-7 and 10-12 before calculating the filing fee as shown in the following listing of claims, which replaces all prior versions and listings of claims.

1. (original) An ion beam apparatus comprising: a holder member which holds a sample; and

a removing beam source which irradiates a gaseous ion beam onto a processed surface of a sample hole by the holder member and removes a fracture layer on the processed surface, the processed surface being formed by irradiating a focused ion beam,

wherein the gaseous ion beam is irradiated from a holding end side of the sample with respect to a direction vertical to the processed surface so that its irradiating direction is tilted with respect to the vertical direction.

- 2. (original) The ion beam apparatus according to claim 1 comprising a processing beam source which irradiates a focused ion beam onto the sample held by the holder member and forms the processed surface.
 - 3. 7. (canceled).

8. (original) An ion beam processing method
comprising:

a first step of irradiating a focused ion beam onto a sample and forming a processed surface; and

a second step of irradiating a gaseous ion beam onto the processed surface of the sample and removing a fracture layer on the processed surface,

wherein at the second step, the gaseous ion beam is irradiated from a holding end side of the sample with respect to a direction vertical to the processed surface of the sample so that its irradiating direction is tilted with respect to the vertical direction.

- 9. (original) The ion beam processing method according to claim 8, wherein the gaseous ion beam is an inert gas ion beam.
 - 10. 12. (canceled).
 - 13. (original) A holder member comprising:

a base part which is rotatably supported about a first axis in parallel with the horizontal direction; and

a holding part which is rotatably disposed about a second axis orthogonal to the first axis at a tip end side of the base part and holds a sample where a focused ion beam is irradiated to form a processed surface.

14. (original) The holder member according to claim
13 comprising a drive module which rotates the holding part
about the second axis.